

Form PTO-1449

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

 Attorney Docket No.
062020-1380

 Serial No.
10/751,360

 Applicant
Parks, et al.

 Filing Date
January 5, 2004

 Group
Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initials	Item	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	A						
	B						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	C							
	D							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

E	Jin-Woo Park and Mark G. Allen, Paper entitled "Ultra-Low-Profile Micromachined Power Inductors with Highly Laminated Ni/Fe Cores: Application to Low MHz DC-DC Converters", IEEE Transactions on Magnetics, Vol. 39, No. 5, September, 2003, pp. 3184-3816, 3 pages
	F Charles R. Sullivan and Seth R. Sanders, Paper entitled "Microfabrication of Transformers and Inductors for High Frequency Power Conversion", 1993 IEEE, pp. 33-41, 9 pages.
G	Charles R. Sullivan and Seth R. Sanders, Paper entitled "Microfabrication Process for High-Frequency Power-Conversion Transformers", 1995 IEEE, pp 658-664, 7 pages.
H	Ming Xu, Trifon M. Liakopoulos and Chong H. Ahn, Paper entitled "A Microfabricated Transformer for High-Frequency Power or Signal Conversion", IEEE Transactions on Magnetics, Vol. 34, No. 4, July, 1998, pp. 1369-1371, 3 pages.
I	Jae Yeong Park, Suk H. Han, and Mark G. Allen, Paper entitled "Batch-Fabricated Microinductors with Electroplated Magnetically Anisotropic and Laminated Alloy Cores", IEEE Transactions on Magnetics, Vol. 35, No. 5, September 1999, pp. 4291-4300, 10 pages
J	Jin-Woo Park, Jae Yeong Park, Yeun-Ho Joung and Mark G. Allen, Paper entitled "Fabrication of High Current and Low Profile Micromachined Inductor With Laminated Ni/Fe Core", IEEE Transactions on Components and Packaging Technologies, Vol. 25, No. 1, March 2002, pp. 106-111, 6 pages.
K	Jin-Woo Park, Florent Cros and Mark G. Allen, Paper entitled "A Sacrificial Layer Approach to Highly Laminated Magnetic Cores", 4 pages.
L	Steven D. Leith and Daniel T. Schwartz, Paper entitled "In-situ Fabrication of Sacrificial Layers in Electrodeposited NiFe Microstructures", J. Micromech. Microeng. 9 (1999). Printed in the United Kingdom, pp. 97-104, 8 pages.
M	Chun-Chen Yang and Huk Y. Cheh, Paper entitled "Pulsed Electrodeposition of Copper/Nickel Multilayers on a Rotating Disk Electrode", J. Electrochem. Soc., Vol. 142, No. 9, September, 1995, pp. 3034-3043, 10 pages.

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